PTO/SR/DRN /01-08)

Approved for use through 05/31/2008. OMB 0851-0031
U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

Subotitu	te for form 1449/PTO			e required to respond to a collection of information unless it contains a valid OMB control number. Complete if Known			
Gubbina	10 10 10 11 14401 10			Application Number	10/737,266		
INF	ORMATION	DIS	CLOSURE	Filing Date	December 16, 2003		
STATEMENT BY APPLICANT (Use as many sheets as necessary)				First Named Inventor	Lee Tice		
				Art Unit	2152		
				Examiner Name	Nguyen, Van Kim T.		
Sheet	1	of	1	Attorney Docket Number	9364-90590	_	

		NON PATENT LITERATURE DOCUMENTS		
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		
/V.N./	1	Supplementary European Search Report corresponds to European Application No. EP 04 79 6156 October 15, 2007		
/V.N./	2	Schurgers, C. et al.: "Topology Management for Sensor Networks: Exploiting Latency and Density" Mobilnos 2002. Proceedings of the 3rd. ACM International Symposium on Mobile June 9, 2002		
/V.N./		Ad Hoc Networking and Computing. Lausanne, Switzerland, June 9, 9 June 2002 (2002-06-09), pages 135-145, XP001171557; ISBN: 1-58113-501-7 June 9, 2002		

Examiner Signature	/Van Kim Nguyen/	Date Considered	10/10/2008					
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not								

^{*}EDAMMER: Initial if reference considered, whether or not classion is in conformance with MPEP 699. Draw line through classion if not in conformance and not considered. Include copy of this form when text communication to applicate and the conformation in application of the conformation is required to applicate the conformation is required to the conformation in a present and the conformation is required to the conformation in a present of the conformation is required to the conformation in a present of the conformation is required to the conformation in a present of the conformation is required to the conformation in a present of the conformation is required to the conformation in the conformation is required to the conformation in the conformation is restinated to take 2 hours to complete deplication. The conformation is retired to the conformation in the conformation in the conformation is retired to the conformation in the conformation in the conformation is retired to the conformation in the conformation in the conformation is retired to the conformation in the conformation in the conformation is retired to the conformation in the conformation in the conformation in the conformation is retired to the conformation in the conforma Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.